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Bib Data Sheet

CONFIRMATION NO. 2057

SERIAL NUMBER 09/937,538	FILING DATE 09/25/2001 RULE	CLASS 073	GROUP ART UNIT 2856	ATTORNEY DOCKET NO. 81839.0102
APPLICANTS Michihiro Mizuno, Fukushima, JAPAN;				
** CONTINUING DATA ***** § THIS APPLICATION IS A 371 OF PCT/JP01/00301 01/18/2001				
** FOREIGN APPLICATIONS ***** § JAPAN 2000-16517 01/26/2000				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		STATE OR COUNTRY JAPAN	SHEETS DRAWING 2	TOTAL CLAIMS 18
Verified and Acknowledged Examiner's Signature _____ Initials _____		INDEPENDENT CLAIMS 1		
ADDRESS 26021				
TITLE Method for evaluating concentration of metallic impurities in silicon wafer				
FILING FEE RECEIVED 860	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	